

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

<b>In re United States Patent Application of:</b>	<b>Docket No.: 4240-104</b>
<b>Applicants: JUNG, Hee Tae, et al.</b>	<b>Conf. No.: 9621</b>
<b>Application No.: 10/805,044</b>	<b>Art Unit: 1639</b>
<b>Date Filed: March 19, 2004</b>	<b>Examiner: Christopher M. Gross</b>
<b>Title: METHOD FOR FABRICATING A BIOCHIP USING THE HIGH DENSITY CARBON NANOTUBE FILM OR PATTERN</b>	<b>Customer No.: 23448</b>

**CERTIFICATE OF EFS FILING**

I hereby certify that this document is being filed via EFS in the United States Patent and Trademark Office on January 28, 2009.

/kelly k. reynolds/

**RESPONSE TO OCTOBER 28, 2008 OFFICE ACTION IN  
U.S. PATENT APPLICATION NO. 10/805,044**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This responds to the October 28, 2008 Final Office Action. The time for responding to the October 28, 2008 Final Office Action without extension was set at three months, or January 28, 2009. This Response is therefore timely.

Please amend the claims of the above-identified patent application as set out in **Section I, Amendments to the Claims**, beginning on page 3 hereof.

DO NOT ENTER: /Christopher Gross/ (03/19/2009)